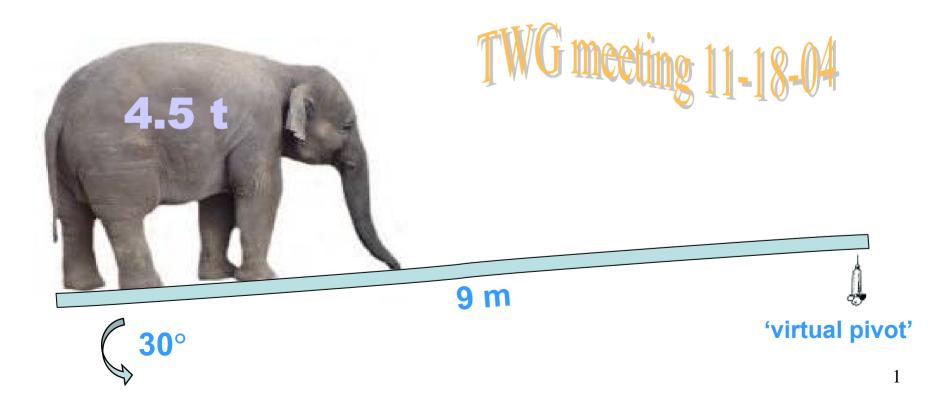
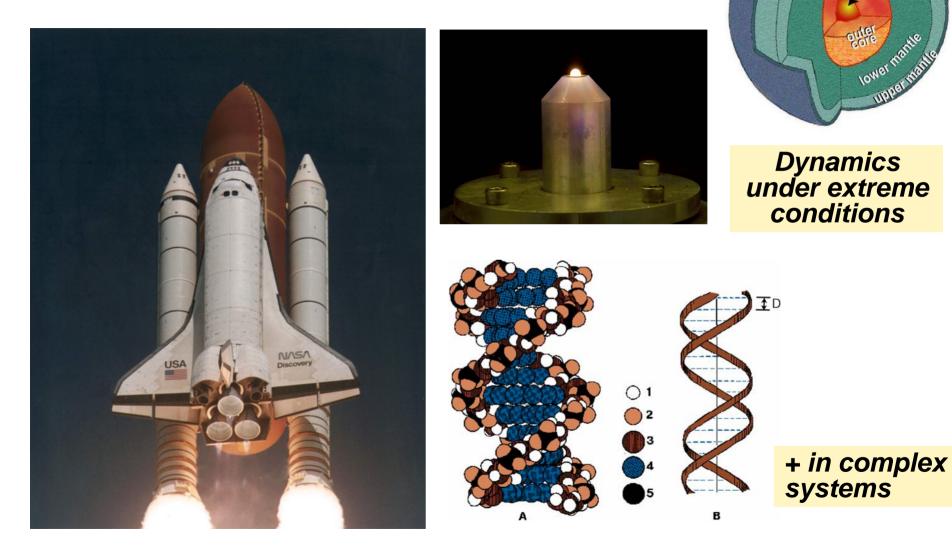
Design of the HERIX spectrometer (IXS-CDT, Sector 30)

Harald Sinn, Bran Brajuskovic, Deming Shu



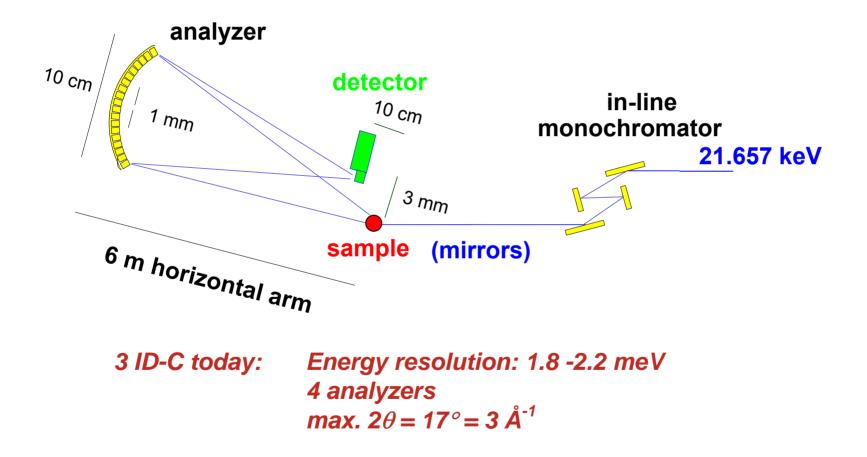
What is IXS good for?



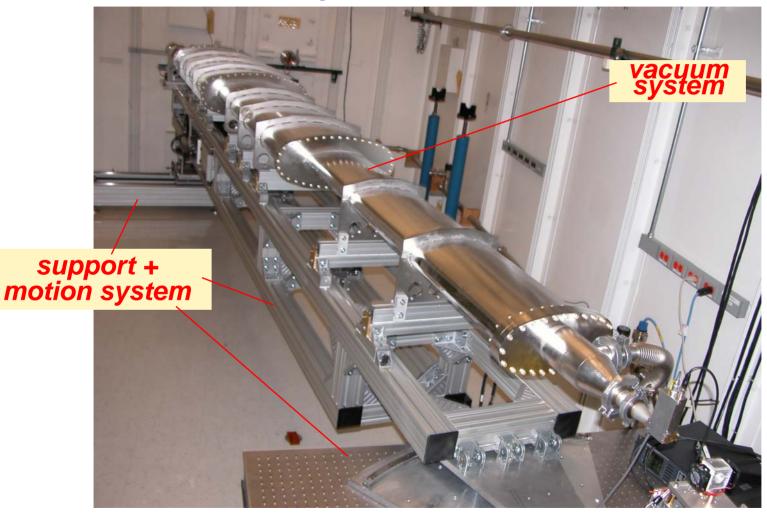
upper manue

crusi

IXS Spectrometer at 3-ID-C



Inelastic spectrometer at 3-ID-C



Design goals for new instrument 'HERIX'

• Enable standard energy resolution of < 1 meV

 $(\rightarrow 9 \text{ m long arm versus 6 m at 3 ID-C})$

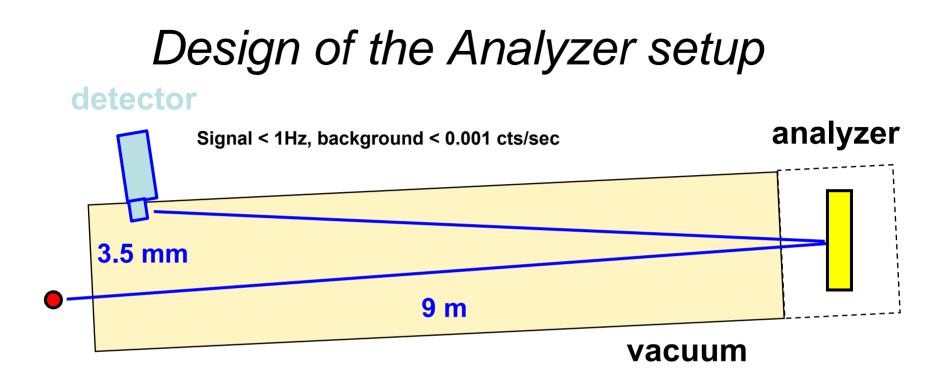
- Maximum number of analyzers with upgrade capabilities (large vacuum)
- Larger 2θ angle (30° versus 15°)
- Large flexibility for various sample environments

 $(\rightarrow$ no real pivot at center of rotation)

• Micro-focusing capabilities (30 x 5 micron)

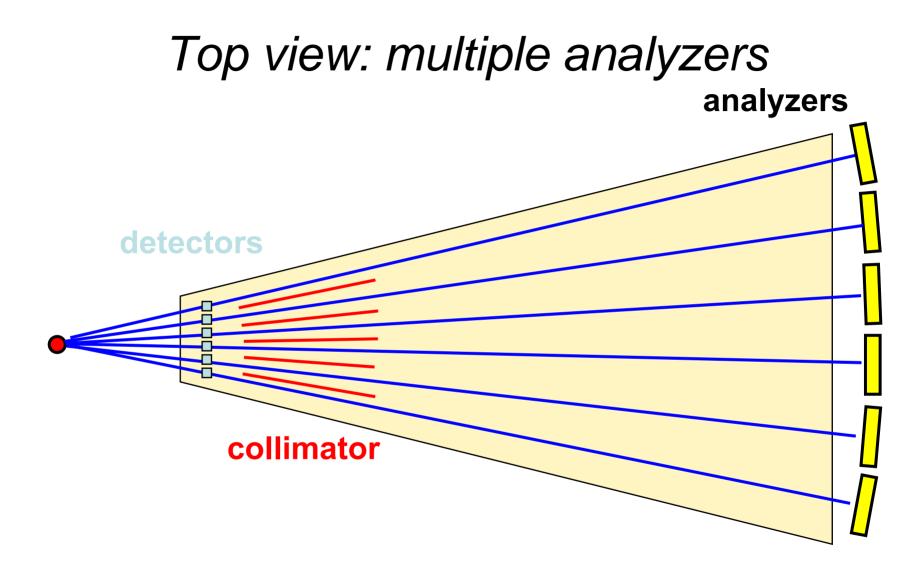
Scientific perspectives

- New experiments in the area of biophysics and nanophysics that require better energy resolution and a small focus
- High pressure experiments

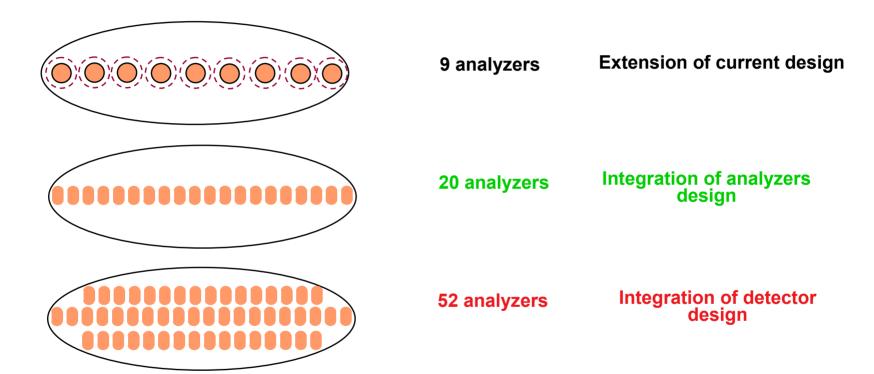


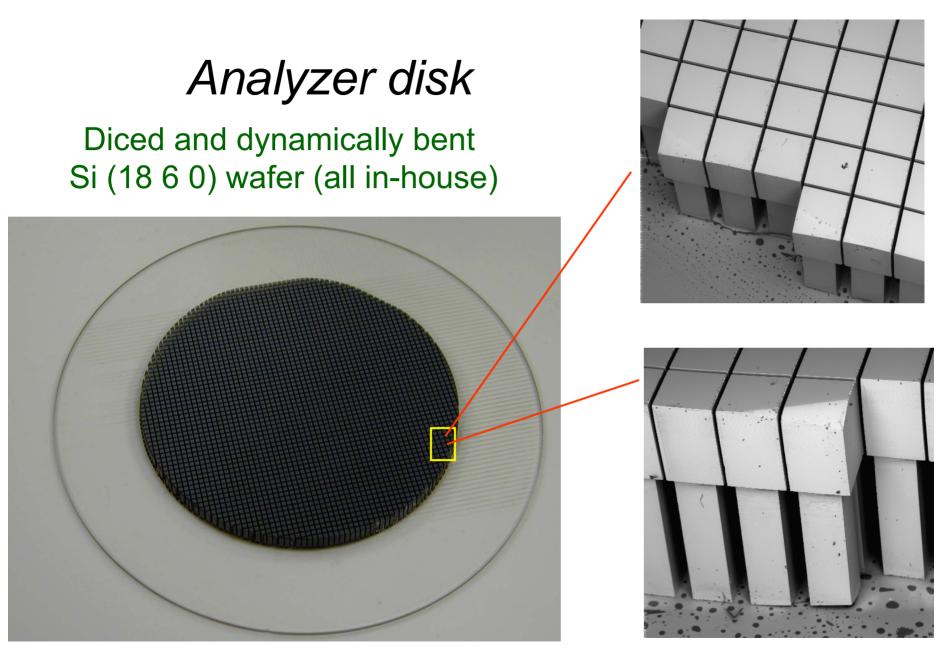
 $I_{Compton} \propto \frac{1}{R^2}_{window}$

 $I_{6m} \approx 2 \times I_{9m}$



Multi Analyzer Setup + Upgrade possibilities







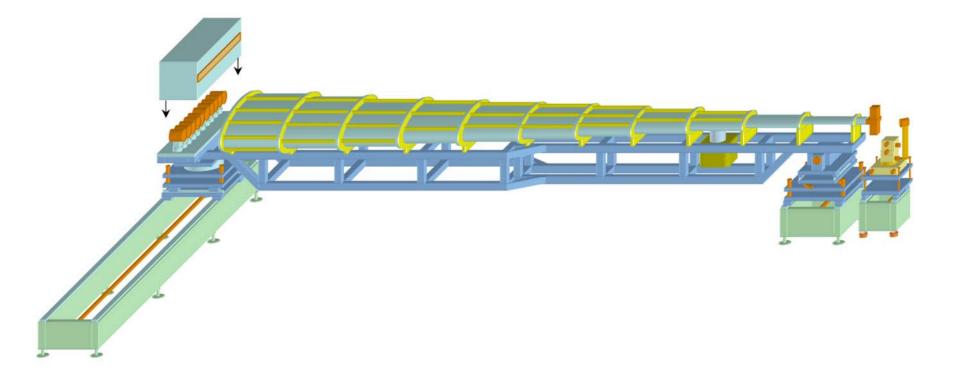
1 x 4 + 1 x 5 element detector



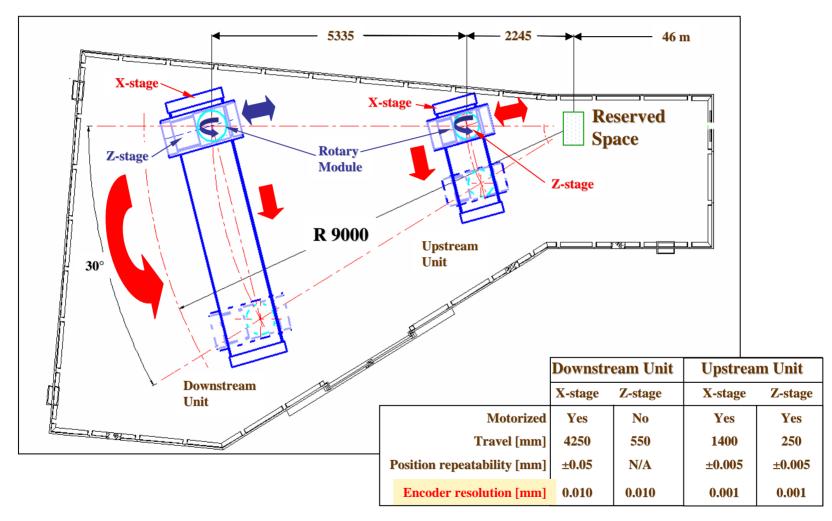


AMPTEK CdZnTe (modified from 1 element standard detector) dark current: 3 cts/hour Efficiency: 1.0 (up to 60 keV) Max. count rate: 10 kHz

Conceptual Layout HERIX (2003)



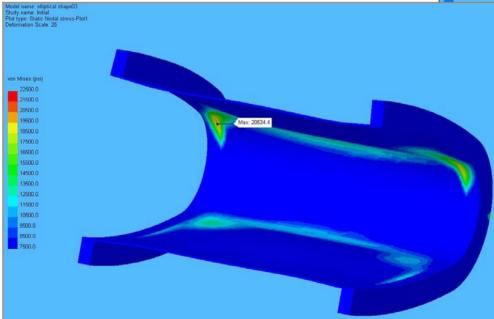
Top view: Station C

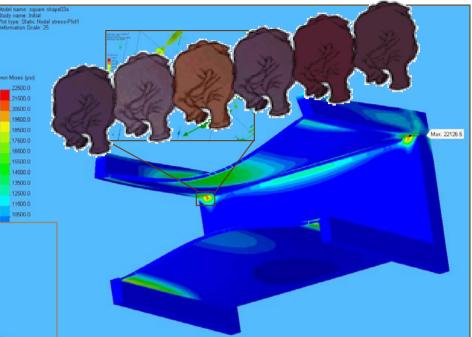


Vacuum chamber

Initial shape optimization

Due to the limited available space only rectangular and elliptical cross-section could be used.





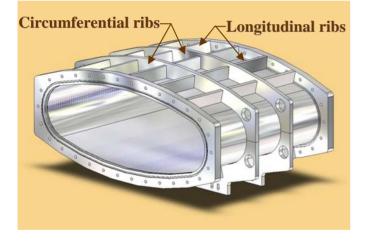
In order to satisfy $s_{max} < 21.5$ KSI, the rectangular chamber should have wall thickness > 5/8" with weight of over 775 kg.

The elliptical chamber with $\frac{1}{4}$ " thick walls satisfies $s_{max} < 21.5$ KSI and weights app. 370 kg less!

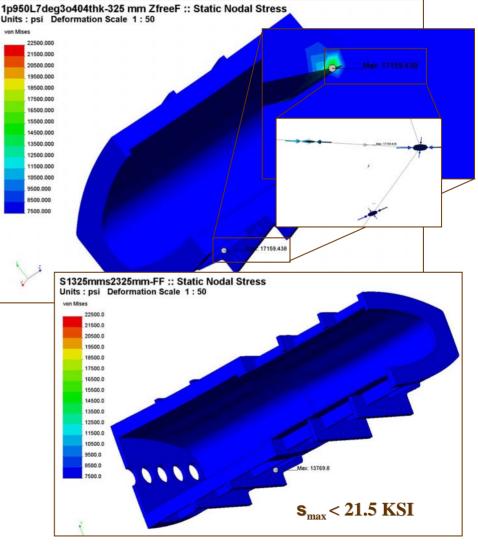
Vacuum chamber

Final shape optimization

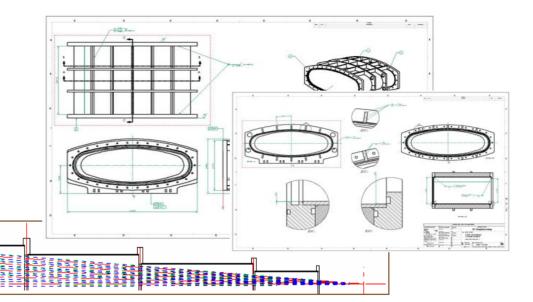
To improve structural characteristics of the chamber segments and provide means to connect them to the supporting arm, longitudinal and circumferential ribs were added.



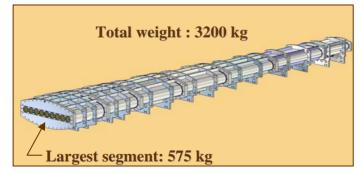
The number, thickness and angular distribution of the longitudinal ribs as well as the thickness and the position of the circumferential ribs were optimized in order to achieve minimum values of stress and deformation of chamber walls.



- 1. Design suitable for HV (~10⁻⁵ Torr) will provide scattering free environment,
- 2. No element of vacuum chamber should obstruct optical path between the analyzer and detector arrays (wide X-section at the analyzer end),



3. Viable for installation and integration into the beam line (segmental design, weight of each segment bellow 1 ton).

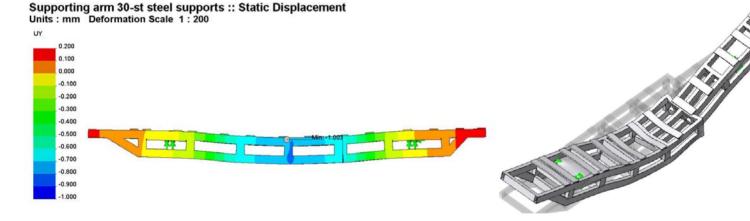




4. Meets Pressure Vessel Safety Code (maximum stresses < 21.5 KSI)

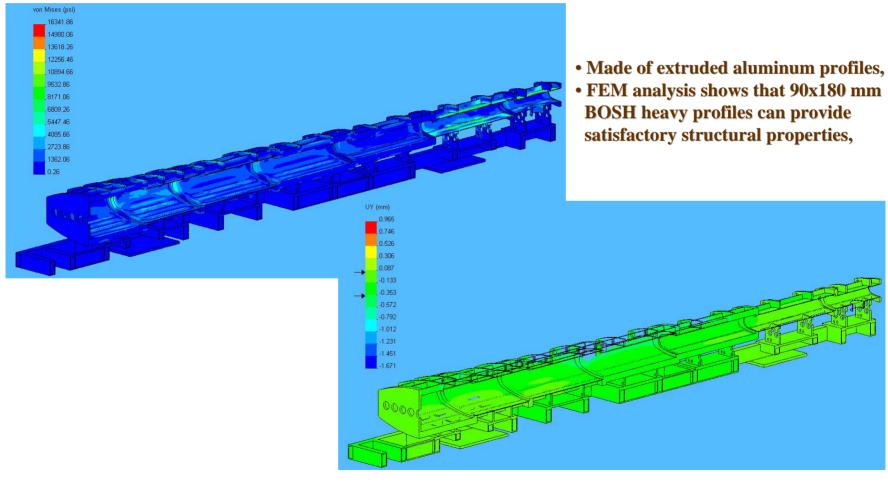
Support Arm

- Made of extruded aluminum profiles,
- Preliminary analysis shows that 80x180 mm BOSH heavy profiles can provide satisfactory structural properties,
- Further optimization needed.



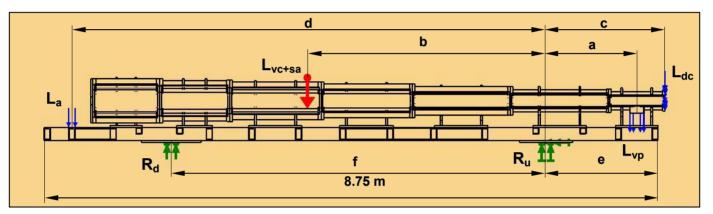
Supporting arm 30-st steel supports f :: Frequency Mode Shape : 1 Value = 27.241 Hz Deformation Scale 1 : 19.4488

'Assembly' or 'Connecting' Arm



Weight distribution

Sizing of the Supports



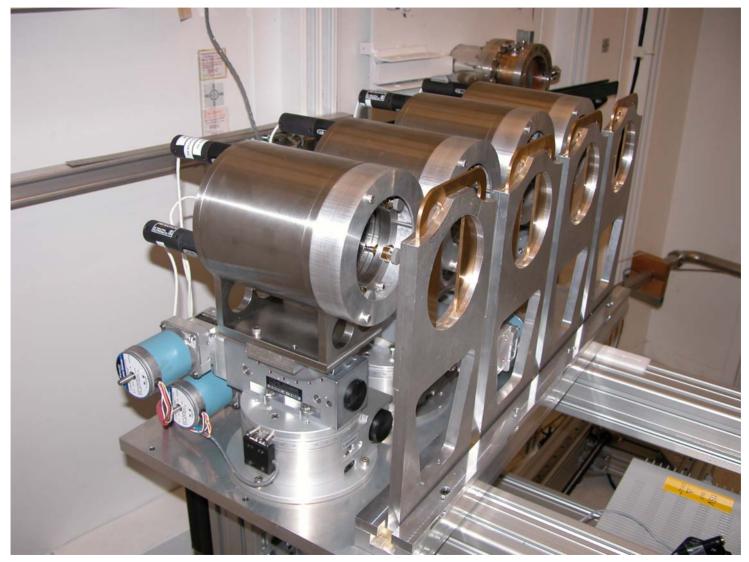
L_a – weight of the analyzer assembly, 250 kg a = 1.29 m L_{vc+sa} – weight of the vacuum chamber and connecting arm, 4200 kg b = 3.4 mL_{vp} – weight of the vacuum pump, 25 kg c = 1.79 m L_{dc} – weight of the detector chamber, 40 kg d = 6.76 m R_u – reaction force, upstream support e = 1.69 m R_d – reaction force, downstream support f = 5.34 m $\Sigma F = 0$: $R_d + R_u - L_{vc+sa} - L_a - L_{vp} - L_{dc} = 0$ $R_{d} = 2985 \text{ kg}$ $\Sigma M = 0: \quad R_d \times f - L_{vc+sa} \times b - L_a \times d + L_{vp} \times a + L_{dc} \times c = 0$ $R_{\rm u} = 1540 \text{ kg}$

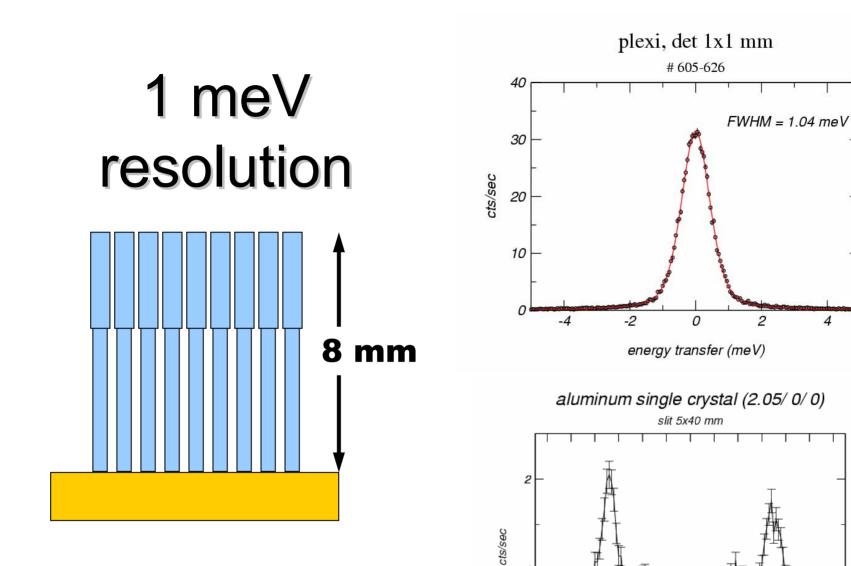
Timeline

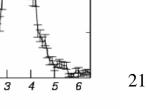
Nov. 2004:Requests for bidMar. 2005:Motion systemMay 2005:Vacuum vesselLater 2005:First test experiments + Analyzer tests



Analyzers







4

n

2

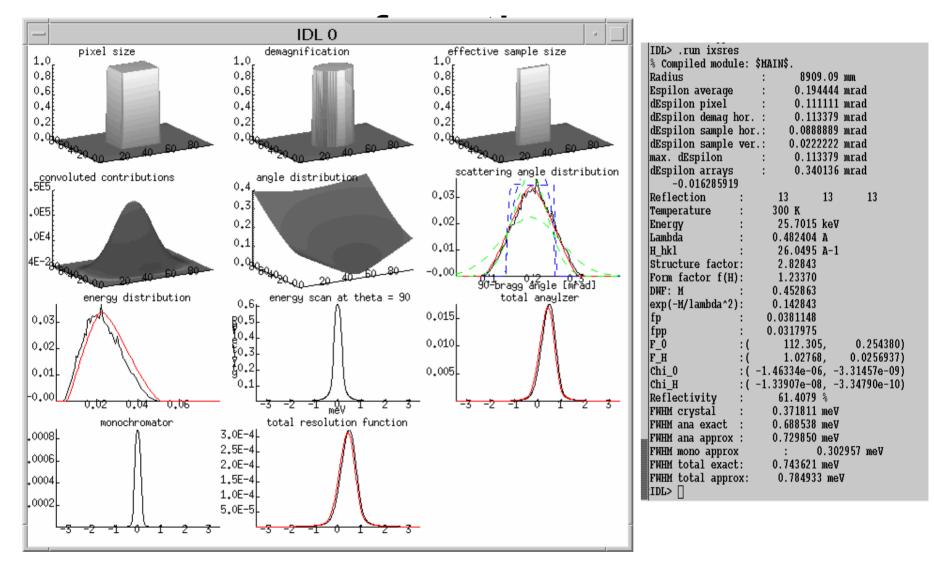
-4 -3 -2

-6

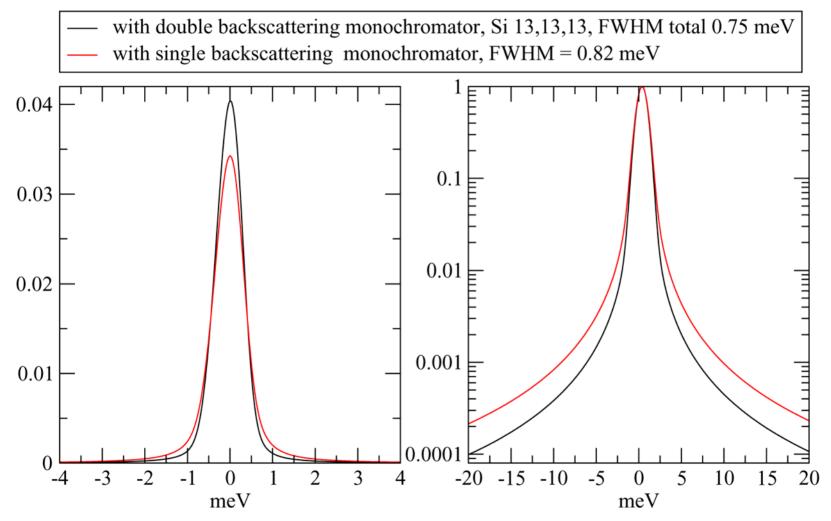
Silicon backreflections

Refl.	7,7,7	12,4,0	18,6, 0	11,11,	13,13,1	15,15,1
E	13.8	14.4	21.6	21.8	25.7	29.6
(keV) [†] ext	40-	30-	200-	280-	600-	1400-
(µm)	250	190	1250	1800	3800	8800
τ _{abs}	300	380	1220	1240	1990	2990
(um)	5.1	6.2	1.2	0.85	0.37	0.15
reflectiv	81%	87%	78%	70%	61%	46%
tot. res.	> 10 meV		2 meV		<	0.4
	•	1meV	meV			

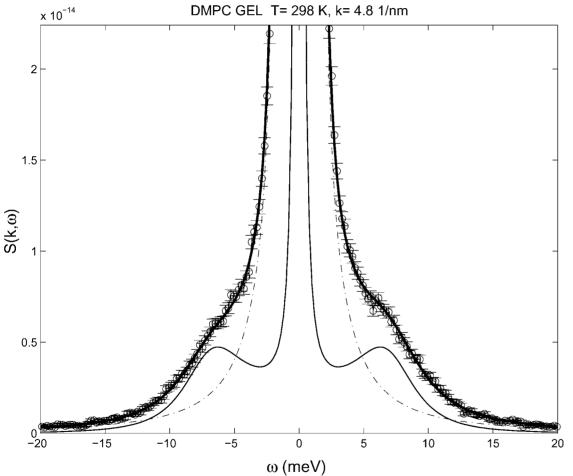
Calculation of the resolution



Resolution function HERIX



IXS Experiment: Lipid Bilayers



Energy resolution: 1.9 meV FWHM

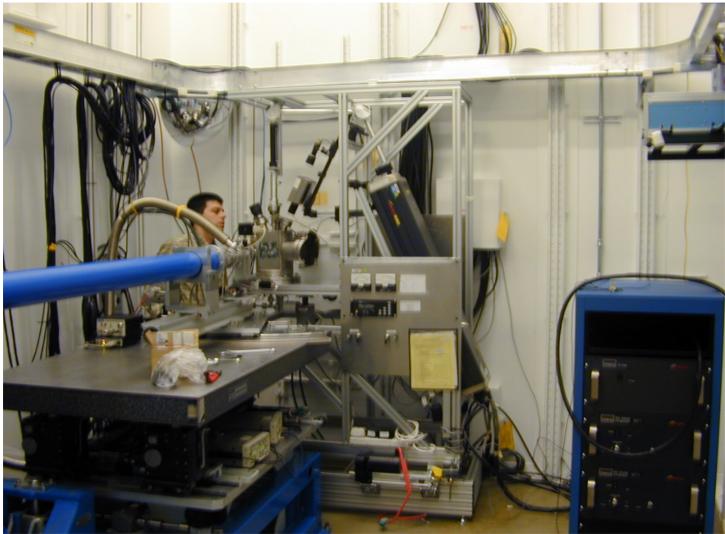


Length of arm

Si 13/13/13 backreflection, DBM, 25.7 keV, beam separation at detector 3.5 mm, 100 mm analyzer

Sample- Analyzer	6	7	8	9 m	10	20	9 m	9 m
	m	m	m		m	m		
Sample- Detector (mm)	18 0	18 0	18 0	180	18 0	18 0	180	90
Pixel size (mm)	1	1	1	1	1	1	0.7	0.7
Overall resolution (meV)	1. 73	1. 21	0. 91	0.7 4	0.6 6	0.4 7	0.6 6	0.5 8

Levitation unit



Single crystals: reciprocal space 1 analyzer: $\delta Q = 0.13 Å^{-1}$ $\boldsymbol{\delta Q}_{vert}$ **10 analyzers:** (0 0 6) (0 0 3) (0 0 0) **1.BZ** $\delta Q_{vert} = 0.16 \text{ Å}^{-1}$ **2.BZ 3.BZ 4.BZ 5.BZ** ... 0.9 Å⁻¹ (030)(0 3 3) (0 3 6)

